

National Center for Electron Microscopy Workshop on Electron Nano-Crystallography April 18-23 2004

Application Form

| Name | | | | |
|--------------------------|-------------------|--------------|-----------------|-------------------------------|
| Position/Title | | | | |
| Organization | | | | |
| Address | | | | |
| | Street | | | |
| City | | | | Country |
| Phone | | Fax | ζ | |
| E-mail address | | | | |
| Knowledge of diffraction | n/ crystallograph | ny/ direct m | ethods etc.(use | e additional sheets if desire |
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Enrollment is limited. Accepted applicants will receive a complete registration packet. The fee to attend is \$300.

Mail or fax the completed form to:

Jane Cavlina, Administrator NCEM/LBNL MS 72 One Cyclotron Road Berkeley, CA 94720

Tel: 510-486-6036 Fax: 510-486-5888